## Notice of References Cited Application/Control No. 10/799,644 Examiner Ren L. Yan Applicant(s)/Patent Under Reexamination HESTERMAN, EBE Art Unit Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	Α	US-5,103,733	04-1992	Drapatsky et al.	101/485
	В	US-5,135,724	08-1992	Dinter et al.	422/186.05
	С	US-6,490,974	12-2002	Wadlinger et al.	101/232
	D	US-6,311,616	11-2001	Kamoda, Hiroyoshi	101/216
	E	US-6,349,641	02-2002	Bayer et al.	101/142
	F	US-			
	G	US-			
	Н	US-			
	ı	US-			
	J	US-			
	к	US-			
	L	US-			
	м	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q	***				
	R					
	S					
	Т					

## NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)						
	U							
	V							
	w							
	x							

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.